



DOCKET NO.: 3905

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF THE APPLICATION FOR PATENT

OF: Takao NAKAMURA et al.

| Art Unit: 2811

SERIAL NO.: 09/519,408

FILED: March 3, 2000

FOR: SEMICONDUCTOR LIGHT-EMITTING DEVICE, METHOD
OF MANUFACTURING TRANSPARENT CONDUCTOR FILM
AND METHOD OF MANUFACTURING COMPOUND SEMI-
CONDUCTOR LIGHT-EMITTING DEVICE

#5
12-10-00
Payton
RECEIVED
DEC 04 2000
TECHNOLOGY CENTER 2800

COMMISSIONER FOR PATENTS

WASHINGTON, D. C. 20231

November 20, 2000

INFORMATION DISCLOSURE STATEMENT AND CERTIFICATE OF MAILING

Dear Sir:

- 1) Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98 applicants enclose a third Form PTO-1449 and a copy of the reference listed thereon. Applicant requests that the references be made of record.
- 2) The undersigned hereby certifies that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Particularly, reference AD was cited in a Japanese Office Action issued in a counterpart Japanese application on August 22, 2000.
- 3) This statement is being filed before the mailing date of a first Office Action on the merits, to the best knowledge of the undersigned.

- 4) The cited reference AD is accompanied by an English language Abstract. The Japanese Examiner in the above-mentioned Japanese Office Action asserted that reference AD (at col. 6, lines 22 to 25) discloses that it is well known that laser ablation can be used to prepare a transparent film of high transmittance and low resistance. The Japanese Examiner's assertion is not adopted or ratified by the applicants, but should be taken into consideration by the U. S. Examiner.
- 5) Also, the Japanese Examiner asserted that JP 6-318406 (previously cited reference AA) discloses the same target material as recited in the present application.
- 6) Applicant respectfully requests that the Examiner consider all references of record, return an initialled copy of the enclosed second Form PTO-1449 and ensure that all references of record are printed on any patent issuing from this application.
- 7) Favorable consideration and allowance of claims 1 to 15 are respectfully requested.

Respectfully submitted

Takao NAKAMURA et al.
Applicant

WFF:ar/3905
Enclosure: postcard,
Form PTO-1449,
1 reference

By Walter F. Fasse
Walter F. Fasse
Patent Attorney
Reg. No.: 36132
Tel. No.: 207-938-4422
Fax. No.: 207 938 2323
P. O. Box K
St. Albans, ME 04971

CERTIFICATE OF MAILING:

I hereby certify that the foregoing Information Disclosure Statement with enclosures is being mailed on November 20, 2000 as first class mail, postage pre-paid, in an envelope addressed to: Commissioner for Patents, Washington, D. C. 20231.

Anita Morse - November 20, 2000
Anita Morse - November 20, 2000